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P. 03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: SHIMBORI et al. Docket No.: 372106-105 (338531)
Serial No. 10/628,919 Art Unit: 1756
Filed: July 29, 2003 Examiner: Young, Christopher G.
Title: PHOTORESIST PATTERN AND FORMING METHOD THEREOF

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE & AMENDMENT UNDER 37 CFR 1.116

Dear Sir:

In response to the Final Office Action mailed April 4, 2006, Applicants submit the following amendments and remarks.

Amendments to the claims begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.